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Controlled Thermal Nitridation Resulting in Improved Structural and Photoelectrochemical Properties from Ta₃N₅ Nanotubular Photoanodes

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Ta₃N₅ nanotubular photoanodes were synthesized by thermal nitridation of anodized Ta₂O₅ nanotubes (NTs) in a temperature range from 650°C to 1000°C. XRD diffractograms and Rietveld Refinements show that the crystalline structure is strongly dependent on thermal nitridation that triggers defects in the orthorhombic structure of Ta₃N₅ NTs. A non-stoichiometric Ta₃N₅ phase was observed at the bottom of the Ta₃N₅ NTs at Ta–Ta₃N₅ interface. Electrochemical impedance spectroscopy revealed that nitridation conditions such as temperature and time strongly influence the interfacial charge transportation; affecting the photoelectrochemical (PEC) activities of the photoanodes. Improved PEC performance was obtained from the NTs synthesized at higher temperature for shorter nitridation time. This result is related to the preservation of the tubular morphology obtained at short nitridation time, high crystallinity and lower charge transfer resistance across the semiconductor–electrolyte interface.

Introduction

In recent years, much more efforts have been devoted to the development of technologies to generate and store clean energy. The search for new materials is constantly growing and nanostructured semiconductors have been the focus of intensive study. Tantalum nitride (Ta₃N₅) has received an increasing attention for application in water splitting, mainly due to its near optimal band structure. Ta₃N₅ nanotubes (NTs) have been found to present an enormous potential for applications in photoelectrochemical (PEC) devices. To synthesize Ta₃N₅ that presents tubular morphology at high temperature nitridation; the precursor (Ta₂O₅ NTs) should be synthesized in conditions that result in thick walled nanotubes with increased adherence to the Ta substrate. For Ta₃N₅ presenting tubular morphology, a thorough investigations on lower and higher temperature nitridation at which pristine Ta₃N₅ with tubular morphology can be obtained are warranted.

Electrochemical impedance spectroscopy (EIS) is a powerful tool to study the semiconductor–electrolyte interface. The equivalent circuit (EC) analogy simplifies the elucidation of electrochemical systems; provided the particular arrangement of circuit elements in a network possesses physical meaning. Using EIS and EC to investigate the interfacial charge transportation of Ta₃N₅ NTs synthesized under different nitridation conditions are interesting to understand their PEC activity and to optimize them for improved performance.

In this work, we study the effect of nitridation temperature on the morphology, crystalline structure, interfacial charge transfer, PEC activity and flat band potential of Ta₃N₅ NTs. A detailed investigation is provided to study the Ta₃N₅ nanotubular electrodes prepared at i) increasing temperatures during short nitridation time, ii) increasing temperatures during long nitridation time and iii) fixed temperatures for varying nitridation time.

Experimental

Ta₃N₅ nanotubes preparation

Ta₃N₅ NTs were synthesized by nitridation of Ta₂O₅ NTs prepared by anodization. The anodization was carried out employing a two electrode electrochemical configuration using Ta foil (Alfa Aesar, purity 99.95%) as anode and Cu disk as cathode. The electrolyte was a mixed solution of H₂SO₄ (Lab-Synth Products Laboratory LTD, 98.0%) + 1 vol% of HF and 4 vol% of distilled water. A DC voltage of 50 V was applied for 20 min by an initial ramping of 10 V/s at 10°C of the electrolyte temperature. Prior to nitridation, the as-anodized samples were etched in HF: H₂O for few seconds, rinsed with water, dried under nitrogen flow, placed on an alumina boat and inserted into a horizontal quartz tube furnace. The heating and cooling rates of the furnace was maintained at 5°C/min under a 100 ml/min of constant gas flux consisting of a special mixture of ammonia: argon (1: 9 v/v). The pressure of the gas from the cylinder was fixed at 5
Results and discussion
Morphology
Fig. 1 displays the SEM and TEM images of the samples synthesized by nitridation for 10 h at 650°C, 800°C and 900°C. One can observe an increase in roughness on the walls of the NTs with the temperature. However, upon thermal nitridation for 10 h at 900°C; a remarkable collapse in the tubular morphology is observed as the nanotubes are shrunk and turn into an urchin-like structure (Fig. 1c). As most of the literature on TaN NTs describes the synthesis at 800°C, we have obtained nanotubes at this temperature and varied the nitridation times for; 1h, 2h, 3h, 5h and 10h.9,15

Photoelectrochemical characterization
PEC measurements were performed using Auto-lab (AUT 84503) potentiostat. The experiments were performed in a quartz cell using the TaN NTs as working electrode, Pt wobbling electrode as counter electrode and Ag/AgCl as reference electrode. The electrolyte was 0.1 M K$_3$[Fe(CN)$_6$] (Merck) and 0.1 mM K$_3$[Fe(CN)$_6$] (Merck) at pH 7.5. Prior to each measurement the electrolyte was purged by argon gas and the TaN NTs photoanodes were cleaned by immersion in HF:H$_2$O for few seconds and subsequently rinsed with distilled water and dried under nitrogen flow. During photocurrent-voltage measurements the working electrode was irradiated with a 300 W Xenon lamp. The polychromatic radiation was filtered by AM 1.5G–filter and the light intensity was calibrated to 100 mW.cm$^{-2}$ (1 sun) using a silicon photodiode. Hand light chopping LSV (linear sweep voltammetry) curves with a 5 sec periodic interval of light On and light Off were obtained at a scan rate of 10 mV/s. Nyquist plots were obtained at a frequency range of 100 kHz – 100 mHz with an amplitude of 5 mV. Mott-Schottky plots were obtained under a frequency of 500 Hz at 5 mV of amplitude for a range of the applied potentials. The measured potential versus the Ag/AgCl was converted to the RHE scale according to the following relation:

$$V_{RHE} = V_{Ag/AgCl} + (0.059) \times pH + 0.197 V$$

Incident photon to electron conversion efficiency (IPCE) measurements were performed at 0 V vs Ag/AgCl using Oriel cornerstone monochromator.
and 750°C-10h have maintained their tubular morphology. Furthermore, it can be seen that the tubular morphology is only sustained at the temperature as high as 900°C (Fig. 2d & 2e), because at 1000°C (Fig. 2c) the nanotubes collapsed and the walls are cracked and periodic holes in the entire length are observed. The nitridation temperatures and times have changed the geometrical dimensions of the Ta3N5 NTs compared to the anodized NTs (Table S1) that is related to the density difference between Ta2O5 and Ta3N5. The key to preserve the morphology of the Ta3N5 NTs for nitridation at higher temperatures lies in the low temperature anodization to prepare Ta2O5 NTs; resulting in strong adhesion to the Ta substrate and presenting thick walls.1,14 The results show that for both conditions of long nitridation time of 10 h at 900°C (Fig. 1c) and for short periods of 3 h at 1000°C (Fig. 2) the nanotubes collapsed. Therefore, to preserve the tubular morphology low temperature anodization of the precursor is beneficial for sufficiently high nitridation temperature applied for short enough time. Furthermore, HRTEM image of the Ta3N5 NTs (Fig. 2f) viewed along [1-10] zone axis displays the interplanar distances of 5.13 and 3.63 Å that are in a good agreement with (002) and (110) plane of the orthorhombic crystalline structure of Ta3N5.

Hereafter, we will discuss the structural characterization for the samples that preserved tubular morphology; however, for comparison the PEC performances of all synthesized samples have been studied.

**Crystalline structure of Ta3N5 nanotubes**

Studying the crystalline structure of Ta3N5 NTs adhere to the Ta substrate by XRD is a challenge task as the Ta foil presents plastic deformation. The characteristic peaks of Ta substrate present high intensity thereby Ta3N5 peaks are hardly seen in the diffractogram. From the XRD patterns recorded by three different approaches; we have provided a comprehensive methodology to study this system (Fig. 3). For comparison, the XRD of the precursor Ta2O5 is displayed in Fig. 3a. Only the diffraction peaks characteristic of Ta can be observed as expected; since the as–anodized Ta2O5 NTs are amorphous.14 After thermal nitridation; the grey colored Ta2O5 NTs turned into red colored Ta3N5 NTs.9 To investigate the presence of Ta3N5 phase we firstly performed conventional XRD of the NTs adhered to the Ta substrate (Fig. 3b). One can observe three different species in the samples; Ta3N5 (PDF# 79-1533), sub–nitride TaN0.3 (PDF# 25-1278) and Ta (PDF# 4-788); their corresponding peaks are marked as *, Δ and O; respectively. In addition, the relative intensity of TaN0.3 peaks increases with the temperature suggesting the increase in the concentration of sub–nitride phases at higher temperatures (Fig. 3b).17 The presence of sub–nitride phase has been earlier reported;11 however, no information is available on the location where it lies in the sample neither on how this phase is formed.

![Fig. 3 XRD patterns of (a) as-anodized Ta2O5 NTs/Ta, (b) and (c) Ta3N5 NTs/Ta, (d) Ta3N5 NTs removed from the substrate and (e) the substrate of which the Ta3N5 NTs are scratched off.](image-url)

The SEM images in Fig. 1 and 2 show that Ta3N5 NTs present a vertically oriented porous structure, allowing the N2 to diffuse from top to bottom to readily replace oxygen by nitrogen resulting in Ta3N5 NTs over the entire nanotube. It has been earlier observed that for the NTs of Ta3N5 the oxygen diffuses to the walls of the NTs and higher temperature nitridation decreases oxygen content.11 Furthermore, according to the literature, pristine tantalum metal cannot readily react under flowing ammonia to form any nitride of tantalum (XRD patterns of pure Ta before and after nitridation under flowing ammonia for high temperatures were exactly the same).18 Therefore, we suggest that the oxygen content that diffuses to the bottom Ta substrate reacts with the Ta atoms...
forming non-stoichiometric oxides which then react with the NH₃ to transform into TaN₂. The Ta and TaN₀.₅ peaks have higher relative intensity compared to TaN₂ phase; therefore, a complete characteristic diffractograms for the whole 2θ range of TaN₂ could not be observed, instead; TaN₀.₅ peaks are visible up to 2θ ~36°. In order to remove the substrate contribution, we have obtained the grazing angle XRD diffractograms of the nanotubes at a very small grazing angle of 0.3° (Fig. 3c). The substrate contributions are almost completely removed and the subnitride TaN₀.₅ (present in conventional XRD) is absent in the grazing angle XRD, showing that TaN₀.₅ is in fact a substrate contribution. In addition, for 650°C-10h the TaN₀.₅ peaks visible in Fig. 3b are nearly absent in Fig. 3c that shows the presence of TaN₂ crystalline grains in amorphous Ta₂O₅ tubular matrix. Grazing angle XRD helped to minimize the contribution from the Ta substrate, however; at the same instant the signal resolution from TaN₂ NTs have been lost. Hence, the NTs were removed from the Ta substrate and powder XRD diffractograms have been obtained for the scratched off NTs (Fig. 3d).¹⁷ The signal resolution is highly improved and all of the observed peaks correspond to TaN₂. Finally, XRD patterns obtained from the substrate of which the NTs were removed have shown just the TaN₀.₅ and Ta characteristic peaks (Fig. 3e) strongly confirming the presence of TaN₀.₅ at the substrate. Nevertheless, we found that TaN₀.₅ is metallic; however, we suggest developing a certain strategy helping to avoiding these phases to synthesize TaN₂ NTs for PEC applications.

With the aim to study pristine TaN₂ NTs free from any other contribution from now onward we will discuss the XRD patterns obtained from the scratched off powders. To investigate the minimum nitridation conditions to obtain TaN₂ NTs we started thermal nitridation at 650°C for 1 h and 3 h. However, at these conditions the presence of a mixed structure of Ta₂O₅ (PDF# 25-922) and TaN₂ (PDF# 79-1533) was observed (Fig. S1) and by increasing the nitridation time from 3h to 6h at 650°C (Fig. S1), clear changes in the XRD patterns are observed once pristine TaN₂ phase is obtained at these conditions. Nevertheless, for 650°C-6h one can observe a huge background in the spectrum along with wide diffraction patterns presenting amorphism in the sample. Therefore, to further improve the crystallinity, we have increased the nitridation time to 10 h at 650°C (Fig. 3d). The diffraction peaks are sharper when compared to 650°C-6 h (Fig. S1); therefore, we fixed the nitridation time for 10 h and varied the temperatures to 700°C, 750°C, 800°C and 900°C. Furthermore, impurities were observed for 800°C-1h (Fig. S1); and by increasing the time to 2 h at 800°C pristine TaN₂ NTs are obtained. Fig. 4 displays the XRD patterns of phase-pure orthorhombic TaN₂ NTs, corresponding to the PDF# 79-1533. Interestingly, when compared to commercial Ta₂O₅ powders which are crystalline in nature, the transformation from Ta₂O₅ NTs to TaN₂ NTs is found to take place at a lower temperature of 650°C.¹⁶ We may suggest that amorphous nanotubular precursors of Ta₂O₅ are easy to transform to TaN₂ at low temperature.

![Fig. 4 XRD patterns of TaN₂ NTs prepared by thermal nitridation.](image)

Crystalline structures were refined by the Rietveld technique. Simulated patterns (Fig. S2) and their respective parameters are shown in Table 1 and Table S2. For the set of samples prepared for 10 h, in addition to slight increase in the grain size the strain is increasing with the temperature (Table 1). The increase in the strain might be related to the morphology preservation and increasing the roughness on the walls of the NTs. The larger crystalline grains and improved crystallinity were obtained for the 900°C-3h TaN₂ NTs. Unlike earlier report on TaN₂ thin films, the grain size for TaN₂ NTs found here presents a dependence on the nitridation conditions.¹⁹ This behavior can be rationalized on the basis of different crystal growth phenomena for thin films and tubular morphology. Once thin films are compact and during the crystal growth; the grains exhibit stress from their neighbor grains that may limit their further growth due to the compact nature of thin films. Therefore, within the limit of stability of TaN₂ phase the grains become independent of the nitridation temperature.¹⁹

<table>
<thead>
<tr>
<th>Sample</th>
<th>Av. Grain Size (nm)</th>
<th>Strain(×10⁻⁴)</th>
<th>Stoichiometry</th>
</tr>
</thead>
<tbody>
<tr>
<td>650°C-10h</td>
<td>29.59</td>
<td>12.15</td>
<td>Ta₂.₃O₅N₂.₇5O₂.₀</td>
</tr>
<tr>
<td>700°C-10h</td>
<td>32.56</td>
<td>19.30</td>
<td>Ta₂.₉₄N₃.₄₅O₁.₂₅</td>
</tr>
<tr>
<td>800°C-5h</td>
<td>31.53</td>
<td>18.67</td>
<td>Ta₂.₉₂N₄.₂₅O₂.₁₂</td>
</tr>
<tr>
<td>800°C-10h</td>
<td>37.46</td>
<td>22.00</td>
<td>Ta₂.₉₅N₄.₂₅O₁.₃₉</td>
</tr>
<tr>
<td>850°C-3h</td>
<td>34.03</td>
<td>32.43</td>
<td>Ta₂.₉₈N₄.₂₅O₂.₄₈</td>
</tr>
<tr>
<td>900°C-3h</td>
<td>43.51</td>
<td>36.90</td>
<td>Ta₂.₉₉N₄.₂₅O₂.₂₂</td>
</tr>
</tbody>
</table>

On the other hand, NTs are isolated from their surrounding exhibiting lower stress from the neighboring grains during the growth; thereby, high temperature nitridation facilitates to increase their size. However, care must be taken for tubular morphology once the morphology can be collapsed under very harsh nitridation conditions.

The percentages of defects in the crystalline structure of TaN₂ NTs are calculated considering the occupation factors obtained by
Rietveld refinement (Table S2). At the Wyckoff sites Ta1(4c), Ta2(8f) and N1(8f) Schottky defects were found. Following the methodology proposed by Henderson et al., the refinements were improved when oxygen substitutional defects are incorporated at the 3-coordinated Wyckoff site N2(4f). These results confirm that oxygen in the crystalline structure of TaN5 cannot be completely removed by thermal nitridation. Based on the refinements, nominal stoichiometries of the samples were calculated from the percentages of site occupancy and vacancy (Table S2) that were obtained from the occupation factors; and are displayed in Table 1. In the set of samples prepared for the nitridation of 10 h, one can observe a decrease in oxygen content by increasing the temperature. However, for 650°C-10h the Ta stoichiometry is “2.94” i.e greater than the other samples but oxygen content are highest; suggesting the presence of large oxygen content in the sample. Therefore, we may suggest; for sample 650°C-10h, the TaN5 crystalline grains are distributed in the amorphous tubular matrix of Ta2O5. In addition, the stoichiometry was not ideal even for 800°C-10h. These results strongly suggest that indeed nitridation temperature of 800°C is not an optimum condition for the synthesis of TaN5. Therefore, the temperature should be increased; however care must be taken to choose an appropriate nitridation time, in order to preserve the tubular morphology. Further details on the crystalline structure of the samples prepared for 3 h of nitridation as a function of nitridation temperature are discussed elsewhere.

Surface elemental composition was investigated by XPS; for the sake of comparison 800°C-10 h and 900°C-3 h were chosen for the analyses. From the survey spectra (not shown) characteristic peaks of Ta, N, O and C were observed. Fig. 5 displays the high resolution XPS spectra of Ta4f and N1s peaks. For both of the samples; in Ta4f region the Ta4f5/2 and Ta4f7/2 doublet are centered at 24.6 and 26.5 eV, respectively with a spin orbital splitting of 1.9 eV. These positions are in line with Ta5+ of TaN5. Furthermore, N1s is positioned at 396.2 eV. These energies are consistent with the previously reported positions observed for TaN5.

Fig. 5. High resolution XPS spectra of (a) Ta4f and (b) N1s region of TaN5 NTs. In N1s region the peak at ca. 403 eV is attributed to Ta4p3/2.

**Optical characterization**

After nitridation a red color was visually observed for the samples indicating the formation of TaN5 NTs. Fig. 6 displays the UV–Vis diffuse reflectance spectra of Ta2O5 and some selected samples of TaN5 NTs. The absorption edges of the TaN5 have been red shifted from the Ta2O5 edge due to narrowing of the band gap. The direct and indirect band gaps were obtained by extrapolating the linear region on the UV-Vis spectra and were found to ca. 2.1–2.2 and 1.93–1.98 eV, respectively consistent with the reported values for TaN5. The absorption spectra of all samples presented tails in ca. 600–800 that has been attributed to the ionic defects.

**Electrochemical impedance spectroscopy (EIS)**

To investigate the effect of nitridation conditions on the charge transfer across the TaN5 NTs-electrolyte interface, we have performed EIS (Fig. 7). Prior to the measurements; the samples were cleaned by successive cyclic voltammetry runs. For the set of samples prepared for the nitridation time of 10 h (Fig. 7a); incomplete semicircles can be observed which are characteristic of capacitance systems exhibiting non ideal behavior. As observed in the TEM images displayed in Fig. 1 (bottom), nitridation for longer time at high temperatures results in a rougher structure, which can affect the charge transportation at the interface. From the single semicircles (one time constant) shown in the Fig. 7a EIS data was fitted to an equivalent circuit (Fig. 7d); consisting of a series resistance R, and single CPE (constant phase element) parallel with
charge transfer $R_{ct}$. The CPE in an electrochemical system may arise from: (a) distribution of the relaxation times due to non-homogeneities existing at the electrode–electrolyte interface, (b) porosity of the electrode, (c) the nature of the electrode and (d) dynamic disorder associated with diffusion.\textsuperscript{25,26,27}

Therefore, based on the nanotubular nature and structural non-homogeneities (SEM and Rietveld refinements) adding CPE for the Ta$_3$N$_5$ NTs–electrolyte interface is physically true. By fitting the Nyquist plots into the proposed equivalent circuit the values of the components have been found and to better visualize the Nyquist plots into the proposed equivalent circuit the values of the parameters of the $R_{ct}$ have been estimated from: (a) distribution of the relaxation times due to non-homogeneities existing at the electrode–electrolyte interface, (b) the nature of the electrode and (c) dynamic disorder associated with diffusion.\textsuperscript{25,26,27}

\begin{figure}[h]
\centering
\includegraphics[width=0.5\textwidth]{fig7.png}
\caption{Nyquist plots for Ta$_3$N$_5$ NTs prepared at different nitridation conditions; obtained under dark (a, b and c) and AM 1.5 (1 Sun) illumination (d).}
\end{figure}

The samples prepared during short and long nitridation times were further probed by EIS, under illumination (Fig. 7d). One can observe that both samples present a decrease in $R_{ct}$. Under illumination the photogenerated charge carriers are separated, thereby facilitating hole transfer from the semiconductor to the electrolyte, which results in a decrease of $R_{ct}$. In addition, 900°C-3h present lower $R_{ct}$ than 800°C-10h, under both conditions (dark and illumination). These results suggest that the sample prepared during longer nitridation exhibit a slower charge transfer at semiconductor–electrolyte interface.

**Mott-Shottky plots**

The flat band potential of the semiconductor is one of the most important parameters for evaluating photoelectrochemical water splitting, which help to predict whether semiconductor should be biased externally or not. One of the most widely used technique to estimate the flat band of a semiconductor is the Mott-Shottky plot.\textsuperscript{28} Fig. 8 displays the Mott-Shottky plots of the Ta$_3$N$_5$ NTs that present n-type transition from the positive slopes of the curves. On each graph the flat band potential ($E_{fb}$) is obtained by extrapolating the linear region which is presented as blue line intercepts. A very interesting result is that all of the samples present almost the same flat band potential of ca. -0.05 vs RHE; therefore, for Ta$_3$N$_5$ NTs, the $E_{fb}$ is almost independent of nitridation temperature. In addition, samples 650°C-10h and 700°C-10h present a lower transition along with the main transition (highlighted in Fig. 8); that can be related to the presence of oxide content which are higher in 650°C-10h than in 700°C-10h.

\begin{figure}[h]
\centering
\includegraphics[width=0.5\textwidth]{fig8.png}
\caption{Mott-Shottky plots of Ta$_3$N$_5$ NTs synthesized at various nitridation conditions.}
\end{figure}

**PEC activity of Ta$_3$N$_5$ NTs**

Fig. 9 shows the Linear Sweep voltammetry (LSV) curves of all the samples. Among the set of samples prepared for 10h of nitridation, 650°C-10h has presented lowest PEC activity which can be related to lower order crystallinity (Fig. 3c) as well as highest interfacial $R_{ct}$.
compared to 800°C-10h. This result can be related to the thermal
Interestingly 800°C-5h presented the higher PEC activity even
the main reasons behind the poor performance of 800°C-1h.
Therefore, the impure phase and low crystallinity are
composition and the electrolyte clearly influences the PEC
1h (Fig. S1). The trade-off between the sample chemical
Fig. 7a). On the other hand the highest photocurrent was obtained
from 900°C-10h that can be related to the improved stoichiometry
of the sample obtained at 900°C compared to the samples prepared
at 800°C (Table 1). For the set of samples prepared at fixed
temperature of 800°C by varying nitridation time (Fig. 9b); the
sample 800°C-1h has shown poor PEC performance. The XRD
analysis presents the mixture of Ta₂O₅ and Ta₅N₃ phases for 800°C-
1h (Fig. S1). The trade-off between the sample chemical
and the electrolyte clearly influences the PEC
performance. Therefore, the impure phase and low crystallinity are
the main reasons behind the poor performance of 800°C-1h.
Interestingly 800°C-5h presented the higher PEC activity even
comparable to 800°C-10h. This result can be related to the thermal
decomposition of the Ta₅N₃ at longer nitridation periods.
Although, 800°C-5h presents the higher photocurrent compared to
other samples of the set; however, the photocurrent is still low,
which can be rationalized in terms of the stoichiometries of the samples
prepared at 800°C for varying nitridation times i.e, which
are far away from the ideal Ta₅N₃ (Table 1). Therefore, 800°C is not
a good choice to synthesize Ta₅N₃ NTs. Considering now the
nitridation of the samples for fixed time of 3h under varying
temperatures; clearly the 900°C-3h presented improved
photocurrent compared to all other samples prepared in the
current work and to those shown in the earlier reports. In
addition, the photocurrent from 900°C-3h is nearly 2-3 fold
more than that obtained from 900°C-10h and 1000°C-3h. Therefore,
the improved photocurrent from Ta₅N₃ nanotubular photoanodes is
in fact a synergistic combination of the tubular morphology, the
controlled chemical composition and the improved charge transfer
across the interface.

![Fig. 9 LSV curves (a, b & c) obtained by chopping AM 1.5 (1 Sun)
illumination and IPCE spectra (d) of Ta₅N₃ NTs.]

Table. S3 shows the parameters obtained from LSV experiments. Th e
Vₘₒ values for pristine Ta₅N₃ NTs are found nearly independent of t he
nitridation conditions. This behavior might be related to the posi
tion of the flat band that was found to be the same for pristine Ta₅N₃ NTs, however, 800°C-1h presented a slightly different Vₘₒ related t o the presence of impurities in the sample.

Fig. 9d shows the incident photon-to-current conversion efficiency
(IPCE) for the samples obtained after short and long nitridation
periods. The IPCE was calculated by the following equation:

\[ \text{IPCE} = \frac{1240 \times \left( \frac{\mu_{ph}}{P_{ph}} \right)}{\lambda} \times 100 \]

where \( \mu_{ph} \) is the photocurrent (in A/m²), \( \lambda \) is the wavelength (in nm)
of incident radiation, and \( P_{ph} \) is the incident light power intensity (in W/m²)
on the semiconductor photoelectrode at the given wavelength. For both samples the IPCE presents a maximum at 500 nm that was 11.8% for 900°C-3h and 2.5% for 800°C-10h, which corroborates the photocurrent obtained from these samples. Furthermore, IPCE spectra follow the same trend as that of UV-Vis absorbance of the samples (Fig. 6), and also comparable to the literature.

Conclusions
In summary, we have performed a throughout study on the effect
of nitridation temperature and time on the synthesis of Ta₅N₃ NTs
by thermal nitridation of the anodized precursor Ta₂O₅ NTs. We
observed that amorphous Ta₂O₅ NTs are easier to transform to
Ta₅N₃ by nitridation at low temperatures; however the samples
obtained at lower temperatures present low crystallinity and poor
photoelectrochemical performance. To synthesize Ta₅N₃ NTs by
thermal nitridation; the temperature should be high enough to
obtain higher crystallinity and the nitridation time should be short
enough to preserve the tubular morphology. The combined effect
of high crystallinity, tubular morphology and low charge transfer
resistance across Ta₅N₃ NTs-electrolyte interface presents an
optimized nitridation condition. Based on Rietveld refinement, EIS
and LSV curves the sample 900°C-3h presents optimum features of a
promising photoelectrode prepared in the current study.

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References
1. Y. Li, L. Zhang, A. Torres-Pardo, J. M. Gonzalez-Calbet, Y. Ma,
P. Oleynikov, O. Terasaki, S. Asahina, M. Shima, D. Cha, L. Zhao,